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FORM PTO-	1449	Docket Numbe 81864	Docket Number (Optional) 81864.0030		Application Number 10/791,598		
INF	ORMATION DISCLOSURE IN AN APPLICATION	Applicant SUGAWARA, et al.					
	(Use several sheets if necess	Filing Date March 2, 2004		Group Art Unit 2873			
		U.S. PATENT	DOCUMENTS				
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Transl YES	ation NO
WC	2000-075244	03/14/00	JAPAN			Abstract	
WC	10-142558	05/29/98	JAPAN			Abstract	
WC	2000-298247	10/24/00	JAPAN			Abstract	
	, ,						
	OTHER DOCUME	NTS (including Au	thor, Title, Date, Pe	rtinent Pages	, Etc.)		

EXAMINER	/William Choi/	DATE CONSIDERED	01/23/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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FORM PTO-1449 Docket Number (Optional) Application Number 81864.0030 10/791,598 **INFORMATION DISCLOSURE CITATION** Applicant Tamotsu SUGAWARA, et al. IN AN APPLICATION (Use several sheets if necessary) **Filing Date Group Art Unit** March 2, 2004 2873 **U.S. PATENT DOCUMENTS EXAMINER FILING DATE IF** DATE NAME CLASS **SUBCLASS DOCUMENT NUMBER APPROPRIATE** INITIAL FOREIGN PATENT DOCUMENTS Translation COUNTRY **CLASS** SUBCLASS **DOCUMENT NUMBER** DATE YE8 NO WC Abstract 09/05/88 **JAPAN** 63-212901 WC **Abstract** 2001-311851 11/09/01 **JAPAN** OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) **DATE CONSIDERED EXAMINER** /William Choi/ 01/23/2007

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